

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: Yi et al.

Examiner: Watson, Joy L

Serial No: 10/827,512

Group Art Unit: 1709

Filed: April 19, 2004

Docket: 8836-242 (IH13145-US)

**FOR: APPARATUS AND METHOD FOR CLEANING SEMICONDUCTOR  
SUBSTRATES**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION**

This amendment is submitted in response to the Office Action dated February 13,  
2008 in connection with the above-referenced application.